



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **FUJIEDA, Tsukasa**

Group Art Unit:

Serial No.: **10/576,193**

Examiner: **Not yet assigned**

Filed: **April 17, 2006**

P.T.O. Confirmation No.: 8608

For: **METHOD OF FORMING LUSTER COATING FILM**

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 CFR 1.97(b)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 17, 2006

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO-1449. One copy of each of these documents is attached, together with a copy of an International Search Report.

No fee or certification is required in connection with this Information Disclosure Statement, since it is being submitted prior to the issuance of a first official action on the merits or expiration of the three month period following the filing date or the entry of the national stage of the above-captioned application.

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

The Commissioner is authorized to charge our Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS,
HANSON & BROOKS, LLP



Donald W. Hanson
Attorney for Applicant
Reg. No. 27,133

DWH/nrp
Atty. Docket No. **060321**
Suite 1000
1725 K Street, N.W.
Washington, D.C. 20006
(202) 659-2930

23850
23850
PATENT TRADEMARK OFFICE

Enclosures: International Search Report
PTO-1449
References (11)



**INFORMATION
DISCLOSURE
CITATION
PTO-1449**

Atty. Docket No. 060321

Serial No. 10/576,193

Applicant(s): FUJIEDA, Tsukasa

Filing Date: April 17, 2006

Group Art Unit: Not yet assigned

U.S. PATENT DOCUMENTS

Examine r Initial	Document No.	Name	Date	Class	Subclas s	Filing Date (If appropriate)
_____	AA					
_____	AB					

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)	
_____	AC	JP 2001-149857 A	6/05/01	Japan	Abstract only
_____	AD	JP 6-51160 B	7/06/94	Japan	Abstract only
_____	AE	JP 9-141195 A	6/03/97	Japan	Abstract only
_____	AF	JP 2002-273333 A	9/24/02	Japan	Abstract only
_____	AG	JP 9-1050 A	1/07/97	Japan	Abstract only
_____	AH	JP 61-74679 A	4/16/86	Japan	Abstract only
_____	AI	JP 2002-86057 A	3/26/02	Japan	Abstract only
_____	AJ	JP 2002-102798 A	4/09/02	Japan	Abstract only
_____	AK	JP 2001-347223 A	12/18/01	Japan	Abstract only
_____	AL	JP 11-300239 A	11/02/99	Japan	Abstract only
_____	AM	JP 62-33578 A	2/13/87	Japan	Abstract only

OTHER DOCUMENTS

_____	AN	
Examiner	Date Considered	



List of publications

	Non-English language documents	English version search report Yes/No	Concise state- ment Yes/No	English trans- lation Yes/No Partial	English abstract Yes/No	First cited in foreign application Yes/No/--* Check after >3 months from filing/ national entry
	Foreign patent : country/number/publication date Publication : author/place/title/page/publicationdate					
(1)	JP 2001-149857 A	Yes	No	No	Yes	--
(2)	JP 6-51160 B	Yes	No	No	Yes	--
(3)	JP 9-141195 A	Yes	No	No	Yes	--
(4)	JP 2002-273333 A	Yes	Yes	No	Yes	--
(5)	JP 9-1050 A	Yes	No	No	Yes	--
(6)	JP 61-74679 A	Yes	No	No	Yes	--
(7)	JP 2002-86057 A	Yes	No	No	Yes	--
(8)	JP 2002-102798 A	Yes	No	No	Yes	--
(9)	JP 2001-347223 A	Yes	No	No	Yes	--
(10)	JP 11-300239 A	Yes	No	No	Yes	--
(11)	JP 62-33578 A	Yes	No	No	Yes	--

◆ Please note that publications (1)-(11) were cited in the International Search Report mailed on February 1, 2005 during the international phase of the instant PCT application.

◆ Please note that publication (4) was a document cited in the specification.

☐ We are also note that publication ____ corresponds to publication ____.



Concise statement of relevancy

Japanese Unexamined Patent Publication No.

2002-273333 discloses a method of forming a luster coating film,
5 in which a luster base coating is formed on a substrate in two
stages, followed by forming a clear coating, the thickness ratio
of the base coating composition applied in the first stage to
that applied in the second stage being 2/1 to 4/1. This method
can prevent unevenness in the luster of luster coating films.

10 However, especially when an aqueous luster base
coating composition is used, the above method is likely to
result in insufficient orientation of the flaky luster pigment
used, and is not capable of forming a luster coating film with
a highly dense texture and high flip-flop property.

15